



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 9, 2026	
IGI Report Number	LG799691990
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	13.86 X 9.75 X 6.66 MM

GRADING RESULTS

Carat Weight	7.93 CARATS
Color Grade	E
Clarity Grade	VVS 2

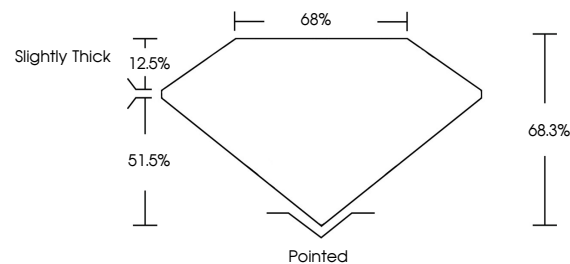
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	131 LG799691990

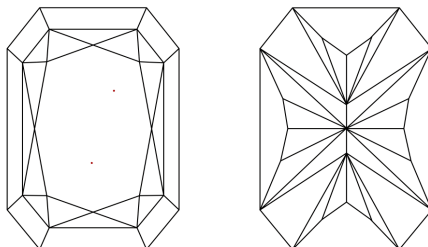
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG799691990
Report verification at igi.org

PROPORTIONS

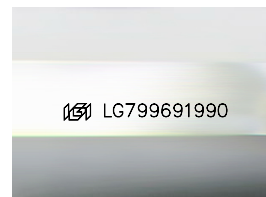


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

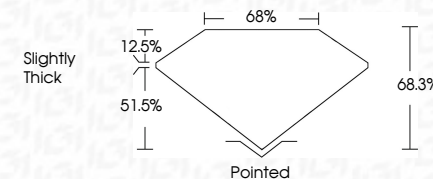
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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May 9, 2026	CU Patent No. LG795691990	7.9% CUBATS
CU CORNERED RECT. MODIFIED BRILLIANT		E
13.86 X 9.75 X 6.66 MM		VWS 2
		68.3%
		68%
		Slightly Thick
		Pointed
		EXCELLENT
		EXCELLENT
		NONE
		1691 LG795691990

Comments: 1. Many Grow Vapor Deposition
 created by Chemical Vapor Deposition
 CVD growth process.
 type IIa